

SEP 2 2 2006

PATENT 8007-1111

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicants: Atsushi SAKURAI et al. Confirmation: 1454

Serial No.: 10/583,942 Art Unit: Not assigned

Filed: June 22, 2006 Examiner: Not assigned

For: METAL COMPOUND, MATERIAL FOR THIN FILM

FORMATION, AND PROCESS OF FORMING THIN FILM

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents September 22, 2006
P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

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In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the references listed on the accompanying Form PTO-1449 are hereby made of record in the above-identified application. These documents are cited in the present specification or correspond to a reference cited in the specification. The discussion in the specification, together with the enclosed English language abstracts, constitutes a concise explanation of the relevance of the foreign references.

This Information Disclosure Statement is being submitted within three months of the filing date of this application; therefore, no fee is required.

Respectfully submitted,

YOUNG & THOMPSON

Benoît Castel, #35,041

745 South 23rd Street Arlington, VA 22202 703-521-2297 (telephone) 703-685-0573 (telecopier I) 703-979-4709 (telecopier II)

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	Inorganic Chemistry, Vol. 29,	No. 23, 1990, pp.	4640-4646.					
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EXAMINER:			DATE CONSIDERED					
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^{*} English language abstract provided for the Examiner's convenience